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# MSPM Lite Micro Suspension Part Measurement

Module of the KLIPPEL ANALYZER SYSTEM (Document Revision 1.10, dB-Lab 212)

#### **FEATURES**

- Linear parameter measurement for suspension of micro-speakers, headphones, tweeters, microphones
- Resonance Frequency & Q-Factor
- Sound pressure excitation for measurement of bare membrane without attaching a voice coil

#### **BENEFITS**

- Parts testing before driver assembly
- Specification of suspension parts
- Optimal driver design in R&D



Name	Value	Unit	Description
<i>f</i> r	896.4	Hz	Resonance frequency
Q	3.74	-	Quality factor
т	0.051	g	Moving mass
С	1.787	mm/N	Mech. Compliance
K	0.559	N/mm	Stiffness
R	0.026	Kg/s	Mech. resistance

#### DESCRIPTION

The *MSPM Lite Micro Suspension Part Measurement* software module and hardware accessory for the KLIPPEL R&D System is designed for the measurement of the linear mechanical parameters of small suspension parts (Micro-speakers, headphones, tweeters, microphones).

The membrane is excited passively by the sound pressure in a pressure chamber and the linear parameters: resonance frequency, Q-factor, stiffness, moving mass and mechanical resistance are determined dynamically by a simultaneous measurement of displacement and sound pressure.

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#### #2500-603

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#### **1** Overview





Linear Parameters	By either using the Added Mass Method, or by importing a known moving mass, the linear mechanical parameters resistance <i>R</i> , stiffness <i>K</i> and moving mass <i>m</i> can be calculated from the resonance frequencies and Q factors.					
	Comment					
	Results					
	fr	896.39	Hz	Resonance frequency		
	Q	3.74	-	Quality factor		
	m	0.0176	g	Moving mass		
	C	1.7872	mm/N	Mechanical compliance		
	ĸ	0.5595	N/mm	Stiffness		
	R	0.0265	kg/s	Mechanical resistance		
	L					

## 2 Requirements

2.1 Hardware		
MSPM Bench (Item #2500-604)	The MSPM Bench comprises a small pressure chamber with a flexible clamping mechanism for micro suspen- sion parts. The built-in driver generates the sound pressure that can be measured by a 1/4-inch micro- phones via the provided feed-through.	
Laser Stand	<ul> <li>The MSPM Bench is designed to work with one of the fores</li> <li>3D Scanner (Scanning Vibrometer System SCN)</li> <li>LST Bench (Item # 2500-310) + Translation Stage</li> <li>Pro Driver Stand (Item #2211-100) + Translation</li> </ul>	ollowing laser positioning devic- (Item #2510-004) e (Item #2300-001) n Stage (Item #2300-001)
Analyzer	Both the <i>Klippel Analyzer 3</i> and the <i>Distortion Analyzer</i> are supported to perform MSPM measurements. Both, the <i>ALS</i> (internal map) or LSX (for external amp) configuration of the KA3 are suitable.	
Laser Displacement sensor	A high-precision laser displacement sensor is required. It is recommended to use Keyence LK-H052 Laser sen- sor (Item #2103-200).	
Microphone	A 1/4" microphone is required for sound pressure measurement in the pressure chamber. The recommended microphone is the MIC 40PP-10-S1 (Item # 2400-360).	the shifting the second
Amplifier	A power amplifier is required for performing the measur the internal Amp Card is recommended. For external a Requirements of the KLIPEPL Analyzer System.	rement. For operation with KA3, mplifiers, refer to the Amplifier
Computer	A personal computer is required for performing the me general PC requirements of the KLIPPEL Analyzer System	easurement. Please refer to the
2.2 Software		
dB-Lab	The KLIPPEL dB-Lab R&D software from version 210.12 Lite.	8 is required to run the MSPM
TRF Module	The MSPM Lite control and post-processing modu performed with the Transfer Function Measurement (TR	le is based on meaurements F) module.



## **3** Limitations

3.1 Device Under Test							
Parameter Min Typ Max Unit							
Dimension	DUT dimension limits can be found in A12 MSPM Bench						
Resonance frequency	100		2500	Hz			
Cone break-up frequency <sup>1</sup>	600			Hz			
3.2 Sensors							
Laser Laser limitations can be found in A2 Laser Displacement Sensor							
Microphone	Microphone limits can be found in A4 Microphones						

## 4 Outputs

4.1 Result Curv	Result Curves					
Input Curves	The windo	w shows the measured transfer function $H_{X/P}$ with and without mass.				
4.2 Result Para	4.2 Result Parameters					
Parameter	Parameter Unit Description					
<i>f</i> r	Hz	Resonance frequency of suspension part				
Q	-	Quality factor of suspension part				
m	g	Moving mass				
С	mm/N	Mechanical compliance				
К	N/mm	Mechanical stiffness				
R	kg/s	Mechanical resistance				

## 5 MSPM Bench Specification

5.1 Specification for 1.0 and above					
5.1.1 Maximum/Minimum Ratings Min Max Unit					
Driver nominal impedance 8 Ω					
Input voltage (continuous, < 40 s) 12 V					
Input voltage (short term, < 5 s) 19 V					
Driver used: 18 Sound 6ND410					

Find more specification information in A12 – MSPM Bench.

<sup>&</sup>lt;sup>1</sup> Negligible partial vibrations below the stated frequency

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## 6 References

6.1	Related Modules	<ul> <li>MSPM Pro – Micro Suspension Part Measurement Pro</li> <li>SPM Lite – Suspension Part measurement Lite</li> <li>QC LST – Linear Suspension Test</li> </ul>
6.2	Manuals	MSPM Manual
6.3	Specifications	A12 MSPM Bench

Find explanations for symbols at: <u>http://www.klippel.de/know-how/literature.html</u> Last updated: December 23, 2021 Designs and specifications are subject to change without notice due to modifications or improvements.



## KLIPPEL MODULE OVERVIEW FOR MOVING PARTS MEASUREMENT



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	SPM Lite	SPM Pro	MSPM Lite	MSPM Pro	QC LST Lite	QC LST Pro
R&D System	System 🗸		$\checkmark$		√5)	
QC System	QC System -			-	QC Basic o	r Standard
Base Module	TF	RF	TRF	LPM		-
Analyzer Hardware	Distortion Analyzer 2 Klippel Analyzer 3 <sup>5)</sup>		Distortion Analyzer 2 Klippel Analyzer 3 <sup>5)</sup>		Klippel Analyzer 3 <sup>5)</sup> QC Production Analyzer	
Test Bench	SPM or LST	SPM	MS	PM <sup>6)</sup>	LST, MSPM <sup>6)</sup> or SPM <sup>7)</sup>	
Laser Sensor (Default) (Measurement Range)	IL-030 (+/- 12.5 mm)	LK-H082 (+/- 18 mm)	LK-H052 (+/- 10 mm)		IL-065 (LK-H052 <sup>8)</sup> ) (+/- 10 mm)	
	LK-H022 LK-H052	LK-H052	LK-H022 (+/- 3 mm) LK-H082 (+/- 18 mm) LK-G32		LK-H022 LK-H052	
Laser Sensors (Alternative) (Measurement Bange)	LK-H082	(+/- 10 mm) LK-H152 (+/- 40 mm)			LK-H082	
Nalige/	LK-H152	(+)- 40 mm)			LK-H152	
	LK-G32		(+/- 5 mm)		LK-G32	
Microphone	$\checkmark$	-	,	/	Opt.	✓
Linear Parameters f <sub>0</sub> , Q, k, c, m, r	~	- (only k <sub>eff</sub> )	✓ (only effective)		✓ ( <i>m</i> import, no r)	✓ ( <i>m</i> & <i>k</i> relative, no <i>r</i> )
Nonlinear Parameters <i>K</i> (x), <i>C</i> (x)	-	✓	- 🗸			-
Mass Import	✓	-	$\checkmark$		✓	
Added Mass	✓	-	$\checkmark$	-		-
DUT Ø in mm	30 - 222 <sup>1)</sup> (490 <sup>2)</sup> )	30 – 222 <sup>1)</sup>	< 70		30 - 222 <sup>1)</sup> (490 <sup>2)</sup> ) <70 <sup>8)</sup>	
Frequency Range in Hz	$1 - 100^{4)}$ (200 <sup>3)</sup> )	1-100	100 -	2500	1 – 100 <sup>4</sup> 100 –	<sup>4)</sup> (200 <sup>3)</sup> ) 2500 <sup>8)</sup>

1) Standard Ring Set

2) SPM Bench (with custom ring)

3) LST Bench

4) SPM Bench

5) Min. dB-Lab Release 210

6) MSPM Bench requires additional equipment for laser positioning (SCN Vibrometer, LST-Bench or Pro-Stand)

7) For DUTs with  $\emptyset >= 222 \text{ mm} / <= 490 \text{ mm}$ , customized clamping rings required

8) MSPM Bench